

IAP5 Rec'd PCT/PTO 28 MAR 2006

PTO/SB/08a/b (07-05)

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				Application Number	NEW 10/573786
				Filing Date	March 28, 2006
				First Named Inventor	Osamu YOSHITAKE
				Art Unit	1794
				Examiner Name	Not Yet Assigned Yamnitzky
Sheet	1	of	1	Attorney Docket Number	1752-0182PUS1

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear Pub Date
/MRV/	AA*	US-2003/0146443-A1	05-11-2004	Yamazaki et al.	08-2003
/MRV/	AB*	US-2002/0117662-A1	02-17-2004	Nii	08-2002
/MRV/	AC*	US-2002/0028329-A1	11-08-2005	Ise et al.	03-2002

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear T <sup>6</sup>
	BA**	JP 2001 230070 A	08-24-2001		
	BB**	JP 2003 100767 A	04-11-2003		
	BC**	JP 2003 220275 A	08-15-2003		
	BD**	JP 2003 205084 A	10-18-2002		
	BE**	JP 2002 100476 A	04-05-2002		
	BF**	JP 2004 146368 A	05-20-2004		

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Examiner Signature	/Marie R. Yamnitzky/ (09/19/2008)	Date Considered	09/19/2008
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